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Application Number		10840109
Filing Date		2004-05-05
First Named Inventor	Martir	ı Weel
Art Unit		2448
Examiner Name	Le Hie	en Luu
Attorney Docket Number		1116-063

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	1	5796727	1	1998-08-18	Harrison et al.	
	2	5949776	1	1999-09-07	Mahany et al.	
	3	6675015	B1	2004-01-06	Martini et al.	
	4	6876642	B1	2005-04-05	Adams et al.	
	5	6937860	B2	2005-08-30	Jahn	
	6	6947571	B1	2005-09-20	Rhoads et al.	
	7	6954443	B2	2005-10-11	Forstadius et al.	
	8	6975266	B2	2005-12-13	Abraham et al.	

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	9	7260638	B2	2007-08-21	Crosbie	
	10 7340768 B2		B2	2008-03-04	Rosenberger	
	11 7343160		B2	2008-03-11	Morton	
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	2	20060212478	A1	2006-09-21	Plastina et al.	
	3	20030022675	A1	2003-01-30	Mergler	
	4	20030050062	A1	2003-03-13	Chen et al.	
	5	20030229549	A1	2003-12-11	Wolinsky et al.	

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	6		20040107219	A1	2004-06	i-03	Rosenberger					
	7		20040160307	A1	2004-08	:-19	Saikkonen et a	ıl.				
	8		20050059379	A1	2005-03	i-17	Sovio et al.					
	9		20050245233	A1	2005-11	-03	Anderson					
	10		20060212442	A1	2006-09	1-21	Conrad et al.					
	11		20050021470	A1	2005-01-27		Martin et al.					
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